

a) Amendments to the Specification

*The paragraph beginning at line 5, page 1 of the specification is amended as follows:*

The application is a divisional application of U.S. Application Serial No. 09/997,785, filed November 28, 2001, entitled *Vacuum Ultra-Violet Transmitting Silicon Oxyfluoride Lithography Glass*, by Lisa A. Moore and Charlene Smith, which is ~~The application is a~~ continuation-in-part to U.S. Application Serial No. 09/799,987, filed March 6, 2001, entitled *Vacuum Ultra-Violet Transmitting Silicon Oxyfluoride Lithography Glass*, of Lisa A. Moore and Charlene ~~Smith~~-Smith, which is a continuation application of United States Patent Application Serial No. 09/397,573 filed on September 16, 1999, entitled *Vacuum Ultra-Violet Transmitting Silicon Oxyfluoride Lithography Glass*, of Lisa A. Moore and Charlene Smith, which claims priority to United States Provisional Serial No. 60/135,270 filed May 21, 1999 and United States Provisional Serial No. 60/119,805 filed February 12, 1999, all of which benefit of priority is claimed.